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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:
Bor-Wen Chan, et al.

Serial No.: 10/755,498

Filed: January 12, 2004

For: METHOD OF FORMING A
STACKED CAPACITOR
STRUCTURE WITH INCREASED
SURFACE AREA FOR A DRAM
DEVICE

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Attorney Docket No.
2001.0714C / 24061.605

Customer No. 42717

Group Art Unit: 1765

Examiner: Duy-Vu N. Deo

Confirmation No.: 1284

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

CERTIFICATE OF MAILING

I hereby certify that this correspondence (including any listed enclosures) is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450 on August 10, 2005.

Kristina A. Garcia

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AMENDMENT UNDER 37 CFR §1.111

This Amendment is submitted in reply to the Office Action mailed on May 12, 2005.
(Please see the pages that follow).